CORRIGENDUM CHAPTER - 4

TECHNICAL SPECIFICATIONS FOR ATOMIC FORCE MICROSCOPE

S.N.	Part	Final Specification
1.	AFM System	
2	Scanner	
	X-Y scan range	50 μm x 50 μm or better
	X-Y Position Sensor	Less than 0.5 nm
	Noise	
	Z scan range	10 μm or better
	Noise on the z sensor	0.4 nm or less
	Max. scan speed	5 hz/s or better
3.	Sample	
	Max. sample	More than 90 mm
	diameter	
	Max. sample height	More than 19 mm
	Max. sample weight	3 kg or lower
	Position repeatability	Yes
	(uni-directional)	
	Imaging	With Liquid Imaging Capability
4	Video microscope	
	Camera	5 - Megapixel camera or better
	Field of view	480x360 μm or better
	Spatial resolution	Less than 6 µm
	Focus	Complete Motorized Focus
5	Modes	
	Standard modes	Contact and Tapping Mode
	Optional modes	Conductive electric force microscopy, magnetic force

		microscopy, Inverted Microscope and Nano
		mechanical property mapping
6	Sample Mount	With magnetic and vacuum sample holder.
7	Temperature	-25°C to 110°C or better
	<mark>control stage/stages</mark>	
	<mark>for variable</mark>	
	temperature studies	
8	Software for	Software to comply operation of AFM.
	operation and image	At least 5 License copies for data analysis should be
	analysis	provided.
9	Computer with	Provide Software
	Dual Monitors	1) Which enabled to control complete AFM,
		acquisition of data, and analysis.
		2) Up-gradation in future must be provided free of
		cost.
		3) Branded computer with latest (i-7 or better)
		processor along with at least 23 inch monitor and
		colour printer with antiplexing optic should be
		supplied
10	Accessories	50 pre-mounted contact cantilevers and 50 pre-
		mounted non-contact cantilevers.
11	Warranty Coverage	Three Year warranty
12	Active Vibration	High resolution imaging
	Isolation	
13	Pre-installation	Pre-installation such as room size, tolerable limits of
	requirements	EM field and vibration (mechanical), required power
		rating, utility requirement are to be stated clearly, and
		to be started clearly, and to be verified/surveyed by
		the supplier at the installation site UPS to support
		AFM instrument.

. Training and	(i) All necessary accessories need to attain full
Support	functionality such as connecting lines, fittings,
	wires etc. shall be provided
	(ii) Machine should be installed at NIPER,
	Raebareli (Lucknow campus).
	(iii) Vendor should provide four times training on
	operation and application of the equipment on
	request of user during the initial three year (two
	basic and two advance training).
. Required Documents	Standard samples for calibrating spatial resolution. The
along with technical	supplier must have sold at least 05 AFM System Installed
specifications	in academic and national organization in India in last 10
	<mark>years</mark>